

Department of Electrical and Computer Engineering presents a double seminar:



WALTER SCOTT, JR.
COLLEGE OF ENGINEERING
COLORADO STATE UNIVERSITY

Using Lasers to Enable Next-Generation Technologies

Friday, February 27

1:45–3:00 PM | Nutrien 135

ASML

SEMINAR 1: Advancing EUV Lithography: Innovations in EUV Source Power Scaling

- **Dr. Michael Purvis**, Lead EUV Source Technologist, ASML San Diego

SEMINAR 2: Progress on inertial fusion and implications for fusion energy technology

- **Dr. Jackson Williams**, Program Lead for High-Intensity Laser-Driven Sources, National Ignition Facility, Lawrence Livermore National Laboratory
- **Dr. Emily Sistrunk Link**, Group Leader for Laser Development, Advanced Photon Technologies, National Ignition Facility, Lawrence Livermore National Laboratory



Lawrence
Livermore
National
Laboratory

